

1076237
02/13/02

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10076237	FILING DATE 02/13/2002	CLASS 438	SUBCLASS 480	GAU 2842	EXAMINER JEP/...
**APPLICANTS: Jang Tae-Ho;					
**CONTINUING DATA VERIFIED: NONE MC					
**FOREIGN APPLICATIONS VERIFIED: REPUBLIC OF KOREA 2001-08111 02/19/2001					
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PG-PUB DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>					
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no				ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no				2522-13	
Verified and Acknowledged Examiners's initials <i>KG</i>					
TITLE : Silicon-on-insulator (SOI) substrate and method for manufacturing the same					
U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L (Rev. 12-84)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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